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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): MIURA et al.

Serial No.: 10/808,567

Filed: March 25, 2004

Title: SEMICONDUCTOR DEVICE

Atty. Dkt.: 01-583

Group Art Unit: 2822

Examiner: LEWIS, Monica



Commissioner for Patents
Alexandria, VA 22313-1450

Date: August 29, 2006

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the reference(s) listed on the attached Form PTO-1449 is/are being brought to the attention of the Examiner without any admission that it/they constitute(s) statutory prior art, or without any admission that it/they contain(s) subject matter that anticipates the invention or renders the invention obvious to a person of ordinary skill in the art.

Further, pursuant to 37 C.F.R. §1.97(e), the undersigned hereby certifies that each listed reference was first cited in a Communication (copy and English translation enclosed) from a foreign patent office in connection with a counterpart foreign application not more than three months prior to the filing of this statement. Please note that the English counterpart (US 2003/132530) of JP-A-2001-156225 was already cited in an information disclosure statement in connection with the above-identified patent application filed on

March 25, 2004.

Although no fees are believed to be due at this time, it is respectfully requested that any such fees be charged to Deposit Account 50-1147. Also, the Examiner is requested to initial the attached PTO Form-1449 and to return a copy of same to the undersigned attorney as proof that the listed reference(s) has/have been considered and made of record.

Respectfully submitted,

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FORM PTO-1449	ATTY. DKT NO. 01-583	SER. NO. 10/808,567
APPLICANT MIURA et al.		
FILING DATE March 25, 2004	GROUP 2822	



REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS

FOREIGN PATENT DOCUMENTS

TRANSLATION

		DOCUMENT NUMBER	DATE	COUNTRY	NAME	CLASS	SUB CLASS	YES	NO	
										Eng. Abstract
		JP-A-08-078599	3/22/96	JAPAN						X

* Full English text is available in machine-translated form in JPO (Japanese Patent Office) English language web site at <http://www1.ipdl.jpo.go.jp/PA1/cgi-bin/PA1INDEX>.

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

		First Office Action from Chinese Patent Office issued on July 7, 2006 for the corresponding Chinese patent application No. 200410031258.4 (a copy and English translation thereof)
EXAMINER		DATE CONSIDERED